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(Attorney Docket No. 100209)**

First Inventor: Francesco de Rege Thesauro

Serial No.: 10/807,944

Filing Date: March 24, 2004

Title: Chemical-Mechanical Polishing
Composition and Method for Using
the Same

Examiner: George, Patricia Ann

Art Unit: 1765

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(Sender's signature)**SUPPLEMENTAL RESPONSE TO FINAL OFFICE ACTION**Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450This is a reply is a submission under 37 CFR 1.114 in response to the August 30,
2006 Office communication for the above-captioned U.S. patent application.

Remarks begin on page 2 of this paper.

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